TRAINING

Workshop on Management of Large CryoEM Facilities





Edward T Eng February 7, 2017



THE SCOPE OF TRAINING



NEED FOR TRAINING AT SEMC



SEMC USERS HAVE ACCESS TO ...these available resources IV II Administration/ Instrumentation Personnel ----Computing Training ...given they follow these policies: General policies User policies External vs Internal Staff assistance Lab use Consumables LN2 storage user responsibilities Microscope use Krios clipping After hours Training Safety

TRAINING RESOURCES:

SEMC personnel











Anchi Cheng Sargis Dallakyan Res. Staff Scientist Res. Programmer Zhening Zhang Ca Res. Scientist Res. I

Carl Negro Alex Wei Res. Programmer Technician Phil Baldwin Staff Scientist Bridget Carragher Director







Rapp Priya



Priyamvada Acharya Giovanna Scapin Julia Brasch Embedded Post Doc. Embedded Scientist Embedded Post Doc.



Clint Potter

Director



Crystal Premo Admisistrator

Yong Zi Tan Grad Student

Venkat Dandey

Alex Noble Post Doc. Micah Rapp Grad Student



EM Manager



Ed Eng Ashleigh Raczkowski Kelsey Jordan Staff Scientist Senior Technician Technician Laura Kim Research Associate

EXPERTISE AND REDUNDANCY



LEVERAGING RESOURCES:

7 EMs, sample prep lab, auxiliary

5 people

SEMC

operations team

instrumentation & administration FEI Titan Krios#1 / #2 / #3



FEI Tecnai Biotwin



JEOL 1230

FEI Tecnai F20

FEI Helios 650



Hundreds of users





Bill Rice

EM Manager

Laura Kim Research Associate

Ashleigh Raczkowski Senior Technician Ed Eng Staff Scientis

> Kelsey Jordan Technician

Туре	Frequency	Title	Description
feedback	yearly	General user meeting	State of the center
knowledge	yearly	SEMC EM Course	Theory behind EM Graduate level course
computation	quarterly	SEMC Appion workshop	Data processing workshops
access	monthly	SEMC New User Orientation	Facility use and Safety Training Sample preparation [neg-stain & cryo] Leginon intro/use of screening microscopes
troubleshooting	weekly	User Project Discussion Meetings	Appointments: Mon @ 11am, Thurs @3pm & @4pm
instrumentation	daily	Advanced Leginon use / 1-1 training appointments	Training for independent use of the microscopes and other SEMC resources

Туре	Frequenc	ÿ	Title	Description			
access	monthly	S	EMC New User Orientation	Facility use and Safety Training Sample preparation [neg-stain & cryo] Leginon intro/use of screening microscopes			
Offered once a month							
SEM/TEM users		• 9:30 am • 10:30 am • 10:50 am • 11:30 am	New user orientation Photo & Tour [Ed] Safety (SEMC conf ro Lab overview & ID bac • Sample prep overv • ID badge creation	(SEMC conf room) [Ed] om) [Bill] dge creation ^r iew (Lab) [Ashleigh/Kelsey] [Bill]			
TEM users		• 12:00 pm	Lunch (on your own)				
		• 1:00 pm • 1:30 pm • 3:45 pm	Leginon overview (SEMC conf room) [Ed] Microscope practical (T12 or F20 room) [Laura] Wrap up and brief project meetings [SEMC staff]				

Туре	Frequency	Title	Description					
computat	tion quarterly	SEMC Appion workshop	Data processing workshops					
Cycle offered once a quarter								
	Month 1	Month 2	Month 3					
	Single particle	analysis (2 parts)	Tomography (1 part)					
	Part I	Part II	Part III					
	Appion basics.	3D reconstruction, refinement and	Tomography tools.					
Tools to generate a particle stack and an initial model from micrographs.		validation.						





PROJECT WORKFLOW: GENERAL USE



TEM COMPETENCY

Open signup EMs





+

TVIPS F416

4K CMOS

JEOL 1230 + Gatan US4000 4K CCD

FEI Tecnai 12

Required to take New User training session Required to purchase or assemble their own user tool kit.

Users will be first trained on the J1230 and T12:

Initial sessions require supervision.

To become independent on the EM the user must demonstrate:

- Able to collect images manually or through Leginon.
- On 2 separate occasions in front of 2 different staff members demonstrate holder care, sample insertion and sample retraction.
 - Knows start up and end-of-day shutdown procedures

Moving to the F20:

- User working with a staff member & instrument not being used.
- User screened cryo-grids on the T12.
- Staff comfortable with leaving the user unattended.
- Required to take DE-20 training.

24-hour access:

- Must obtain a C-14 from the FDNY for 24-hour access. ٠
- Must qualify for each instrument.



Pre-allocated EMs



USER TOOLKITS



PROJECT WORKFLOW: GENERAL USE



EM COMPETENCY



Minimal staff assistance

Full staff assistance

STAFF ASSISTED USE ONLY





TRAINING AT SEMC





Training is teaching, or developing in oneself or others, any skills and knowledge that relate to specific useful competencies. **Training** has specific goals of improving one's capability, capacity, productivity and performance.

https://en.wikipedia.org/wiki/Training



Simons Electron Microscopy Center





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Bill Rice

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Ed Eng Staff Scientist



Ashleigh Raczkowski Kelsey Jordan Senior Technician Technician



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Crystal Premo Administrator



National Resource for Automated Molecular Microscopy http://nramm.nysbc.org

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Questions?